

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/533,936	SON ET AL.	
Examiner	Art Unit	
John S. Chu	1795	

	SEARCHED					
Class	Subclass	Date	Examiner			
430	270.1	10/67	Jsi			
430	905	1.	,			
430	910					
526	269					
526	281		·			
526	308					
560	118					
560	128	J				
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
430	270.1,905	16/87	ys c		
430	910	1			
526	269,281				
526/308; 5	560/118,128				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
EAST SEARCH UPDATED	10/67	jse			